


Electronic Filing System (EFS) Data  
Electronic Patent Application Submission  
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10/604146  
06/27/03

EFS ID: 42572  
Application ID: 10604146   
Title of Invention: METHOD OF FORMING SILICON-  
ON-INSULATOR WAFERS HAVING  
PROCESS RESISTANT  
APPLICATIONS  
First Named Inventor: Joel DeSouza  
Domestic/Foreign Application: Domestic Application  
Filing Date: 2003-06-27  
Effective Receipt Date: 2003-06-27  
Submission Type: Utility Patent Filing  
Filing Type: new-utility  
Confirmation number: 1145  
Attorney Docket Number: FIS920030091  
  
Total Fees Authorized: 790.0  
Payment Category: Deposit Account  
Deposit Account Number: 90458  
Deposit Account Name: H. Daniel Schnurmann  
RAM Payment Status: RAM has not been processed

Digital Certificate Holder: cn=H. Daniel Schnurmann,ou=Registered Attorneys,ou=Patent and  
Trademark Office,ou=Department of Commerce,o=U.S. Government,c=US  
Certificate Message Digest: e3f5334a873aa2ddab2355efa1df97b2163693e9

TRANSMITTAL
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Electronic Version v1.1  
Stylesheet Version v1.1.0

<b>Title of Invention</b>	<b>METHOD OF FORMING SILICON-ON-INSULATOR WAFERS HAVING PROCESS RESISTANT APPLICATIONS</b>						
Application Number: Date: First Named Applicant: Joel P. DeSouza							
Confirmation Number: Attorney Docket Number: FIS920030091							
<p>I hereby certify that the use of this system is for OFFICIAL correspondence between patent applicants or their representatives and the USPTO. Fraudulent or other use besides the filing of official correspondence by authorized parties is strictly prohibited, and subject to a fine and/or imprisonment under applicable law.</p> <p>I, the undersigned, certify that I have viewed a display of document(s) being electronically submitted to the United States Patent and Trademark Office, using either the USPTO provided style sheet or software, and that this is the document(s) I intend for initiation or further prosecution of a patent application noted in the submission. This document(s) will become part of the official electronic record at the USPTO.</p> <table border="1"><thead><tr><th>Submitted by:</th><th>Elec. Sign.</th><th>Sign. Capacity</th></tr></thead><tbody><tr><td>H. Daniel Schnurmann Registered Number: 35791</td><td>H. Daniel Schnurmann</td><td>Agent</td></tr></tbody></table>		Submitted by:	Elec. Sign.	Sign. Capacity	H. Daniel Schnurmann Registered Number: 35791	H. Daniel Schnurmann	Agent
Submitted by:	Elec. Sign.	Sign. Capacity					
H. Daniel Schnurmann Registered Number: 35791	H. Daniel Schnurmann	Agent					
<b>Documents being submitted</b> us-fee-sheet  us-ids  us-assignment	<b>Files</b> FIS920030091US1-usfees.xml us-fee-sheet.xml us-fee-sheet.dtd FIS920030091US1-usidst.xml us-ids.dtd us-ids.xml FIS920030091US1-usassn.xml						

us-request

application-body

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### Comments

Assignee Name: International Business Machines Corporation Assignee Address:  
Armonk, NY 10504

**FEE TRANSMITTAL**

Electronic Version v08

Stylesheet Version v08.0

**Title of  
Invention****METHOD OF FORMING SILICON-ON-INSULATOR WAFERS  
HAVING PROCESS RESISTANT APPLICATIONS**

Application Number:

Date:

First Named Applicant: Joel P. DeSouza

Attorney Docket Number: FIS920030091

**TOTAL FEE AUTHORIZED \$790**

Patent fees are subject to annual revisions on or about October 1st of each year.

Filing as large entity

**BASIC FILING FEE**

Fee Description	Fee Code	Amount \$	Fee Paid \$
Utility Filing Fee	1001	750	750
Subtotal For Basic Filing Fee: \$750			

**EXTRA CLAIM FEES**

Fee Description	Extra Claims	Fee Code	Amount \$	Fee Paid \$
Total Claims: 20	0	1202	18	0
Independent Claims: 3	0	1201	84	0
Subtotal For Extra Claims Fees: \$ 0				

**ASSIGNMENT FEES**

Fee Description	Property Number	Quantity	Fee Code	Amount \$	Fee Paid \$
Recording Each Patent Assignment Per Property Fee	00000000	1	8021	40	40

Subtotal For Additional Fees: \$40

**AUTHORIZED BILLING INFORMATION**

The commissioner is hereby authorized to charge indicated fees and credit any overpayments to:

Deposit account number: 090458

Deposit name: International Business Machines Corporation

Deposit authorized name: H. Daniel Schnurmann

Signature: H. Daniel Schnurmann / s /

Date (YYYYMMDD): 2003-06-27

Charge Assignment Fees Required Under 37 C.F.R. Section 1.21 (h).

Charge Any Additional Fee Required Under 37 C.F.R. Sections 1.16 and 1.17.